

<b>Notice of References Cited</b>	Application/Control No. 10/585,612		Applicant(s)/Patent Under Reexamination MIYAHARA, SEIICHIRO	
	Examiner DANIELLE HENKEL		Art Unit 1775	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
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#### FOREIGN PATENT DOCUMENTS

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	N	WO-89/09437	10-1989	WIPO	DEAN et al	G05D 23/20
	O					
	P					
	Q					
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#### NON-PATENT DOCUMENTS

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